



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80433

Makoto MOMOTA, et al.

Appln. No.: 10/802,808

Group Art Unit: 1752

Confirmation No.: 5096

Examiner: Yvette C. Thornton

Filed: March 18, 2004

For: POSITIVE RESIST COMPOSITION AND PATTERN FORMATION METHOD USING  
THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of June 7, 2005 to October 7, 2005.

A check for the statutory fee of \$120.00 is attached. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: October 7, 2005

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